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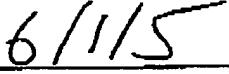
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Applicant's Name: Furnikatsu UESAWA

Serial No. (Control No.): 10/720,851 Examiner: Stephen W. SMOOT

Filing Date November 24, 2003 Art Unit: 2813

Application Title: METHOD OF MANUFACTURING A SEMICONDUCTOR APPARATUS WITH A TAPERED APERTURE PATTERN TO FORM A PREDETERMINED LINE WIDTH

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T-989 P.002/007 F-609

Attorney Docket No. 9792909-5787

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Fumikatsu UESAWA

Group Art Unit: 2813

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Application No.: 10/720,851

Examiner: Stephen W. Smoot

Filed: November 24, 2003

Confirmation No.: 5189

For: METHOD OF MANUFACTURING A SEMICONDUCTOR APPARATUS  
WITH A TAPERED APERTURE PATTERN TO FORM A PREDETERMINED  
LINE WIDTH

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. § 1.111

Sir:

In response to the Office action dated March 15, 2005, please consider the following amendments and remarks.